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Patentee: Jae Heon PARK  
Our Ref: 1857.6730002

Sir:

Transmitted herewith for appropriate action are the following documents:

1. Power of Attorney to Prosecute Applications Before the USPTO; and
2. Statement Under 37 C.F.R. 3.73(b).

***The above-listed documents are filed electronically through EFS-Web.***

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted,

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GJP/awt  
Enclosures

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